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Bib Data Sheet

CONFIRMATION NO. 4154

SERIAL NUMBER 09/833,766	FILING DATE 04/13/2001 RULE	CLASS <u>029</u> <u>700</u>	GROUP ART UNIT <u>3729</u> <u>2125</u>	ATTORNEY DOCKET NO. 862.C2199
APPLICANTS Keiji Emoto, Kanagawa, JAPAN;				
** CONTINUING DATA *****				
** FOREIGN APPLICATIONS ***** JAPAN 2000-112216 04/13/2000				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/06/2001				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged		STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 25
Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>		INDEPENDENT CLAIMS 2		
ADDRESS 05514				
TITLE Pipe structure, alignment apparatus, electron beam lithography apparatus, exposure apparatus, exposure apparatus maintenance method, semiconductor device manufacturing method, and semiconductor manufacturing factory				
FILING FEE RECEIVED 930	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	